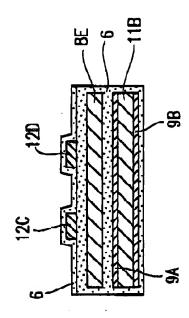
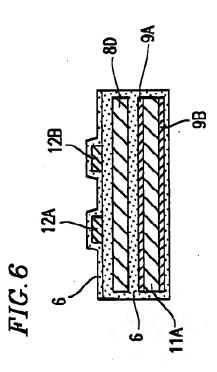
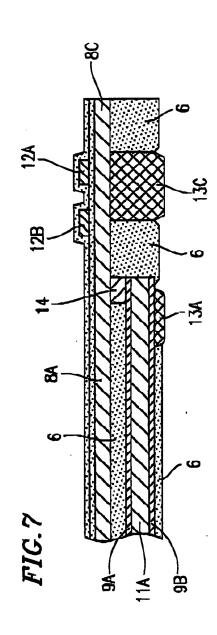
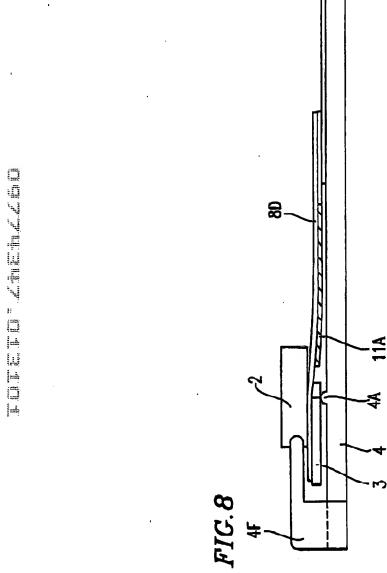


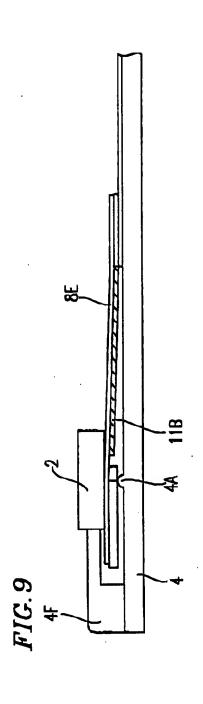
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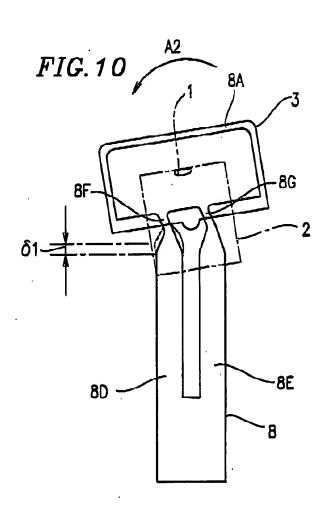


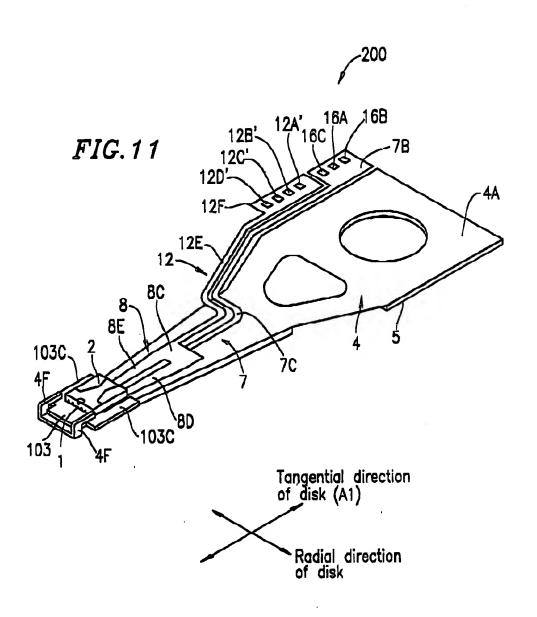


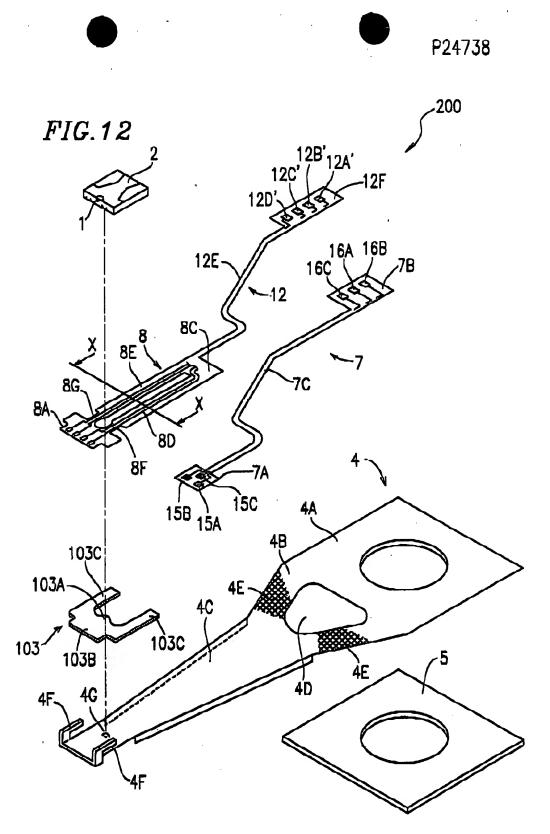


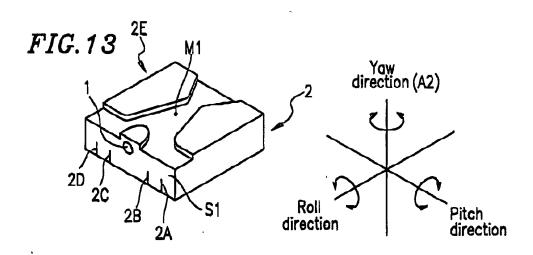


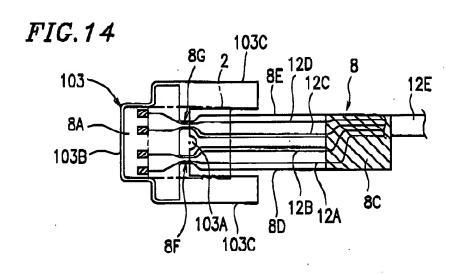












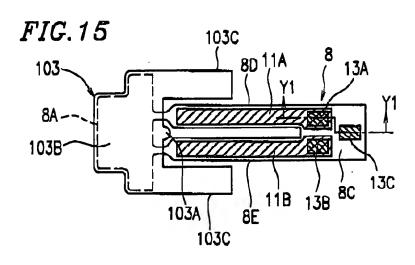
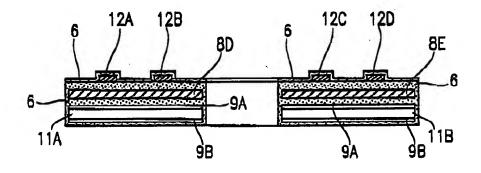


FIG. 16



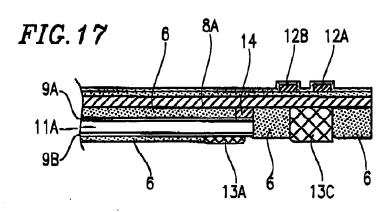


FIG. 18

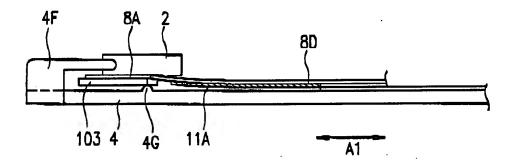
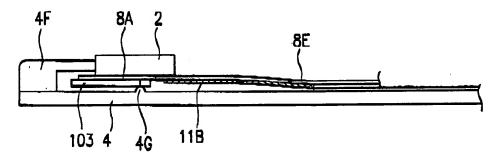


FIG.19



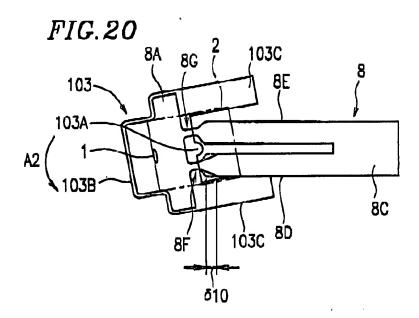


FIG. 21A

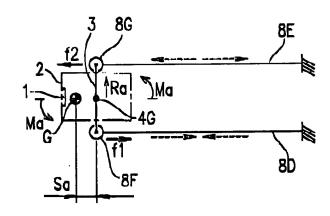
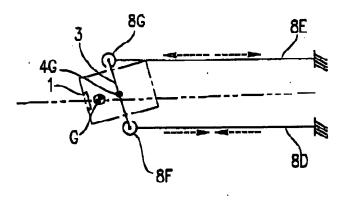


FIG.21B



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FIG. 22A

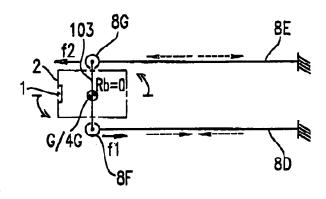
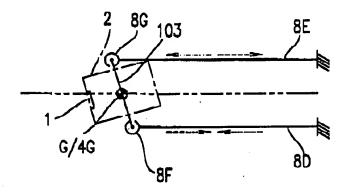
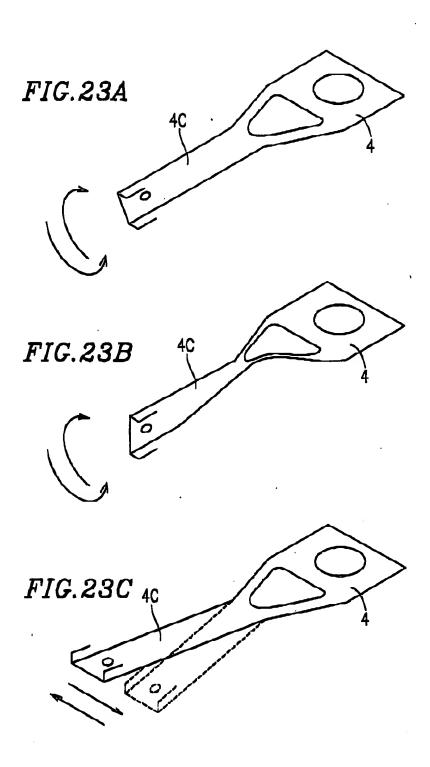
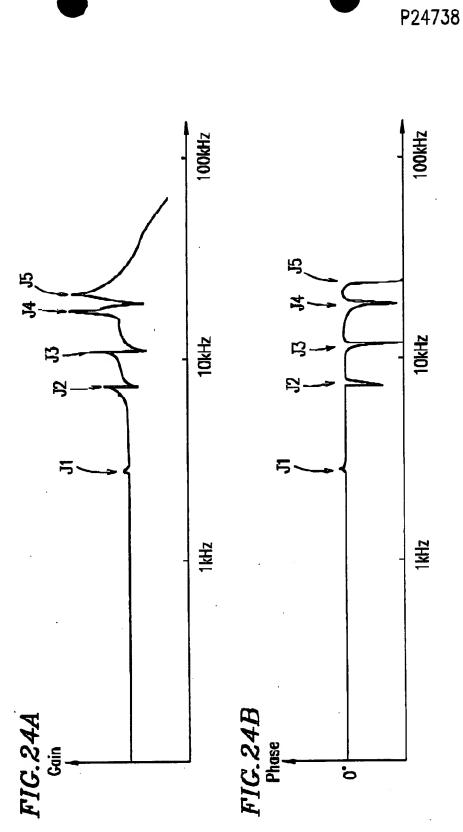


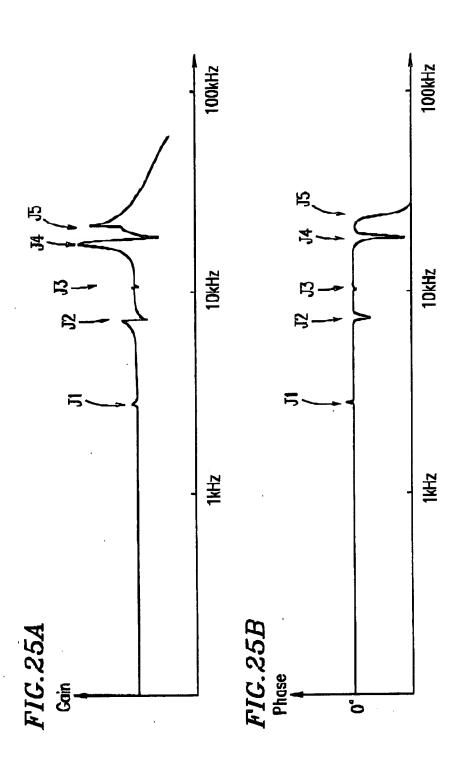
FIG.22B











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FIG.26A

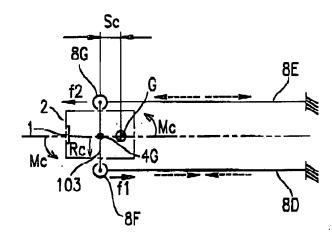
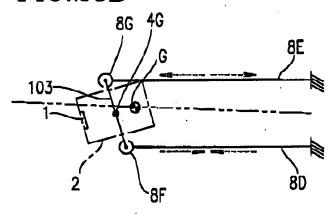
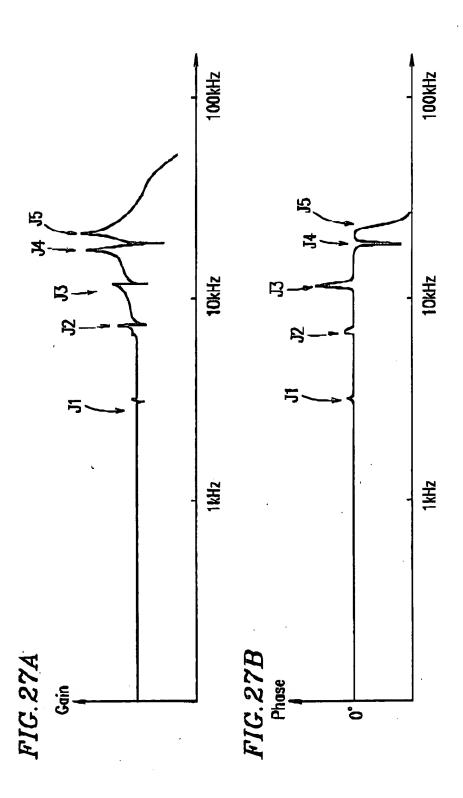


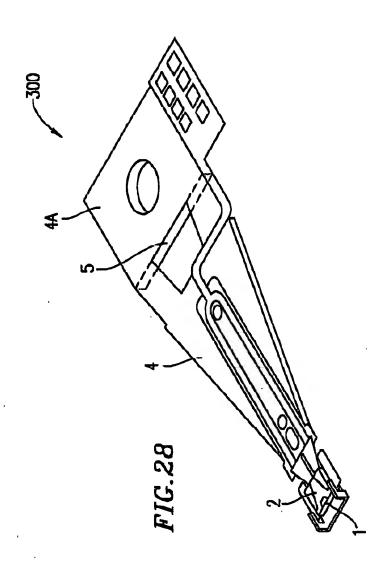
FIG.26B

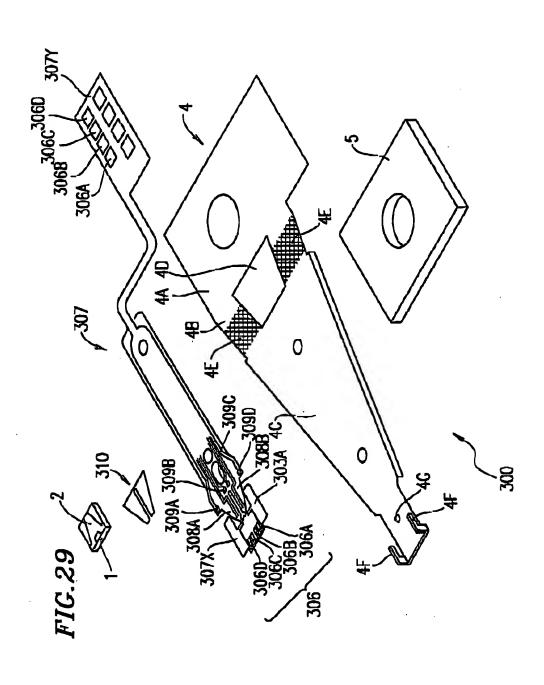


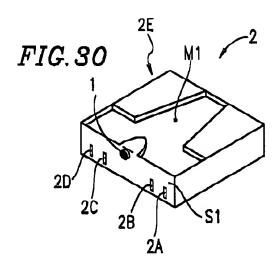


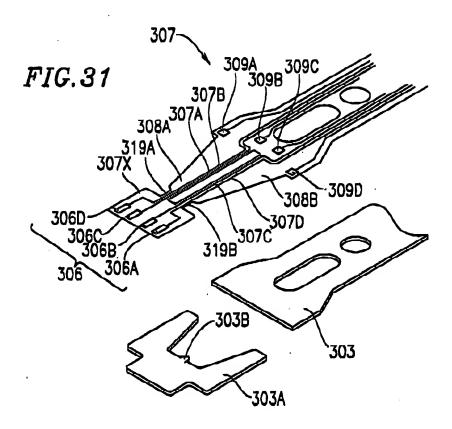


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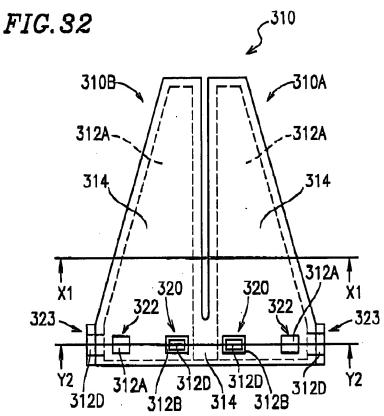


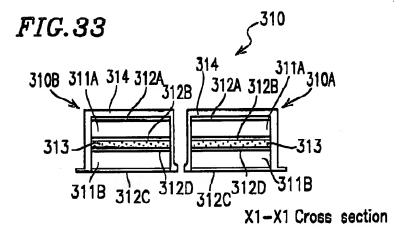


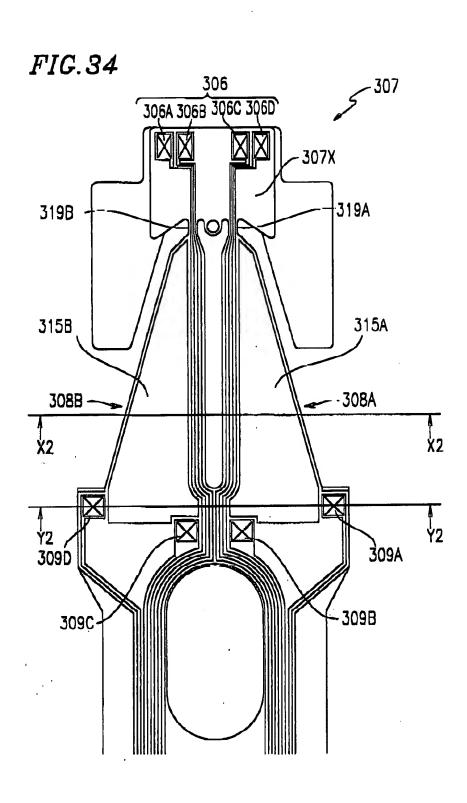


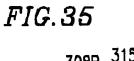


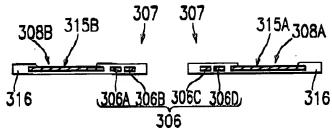




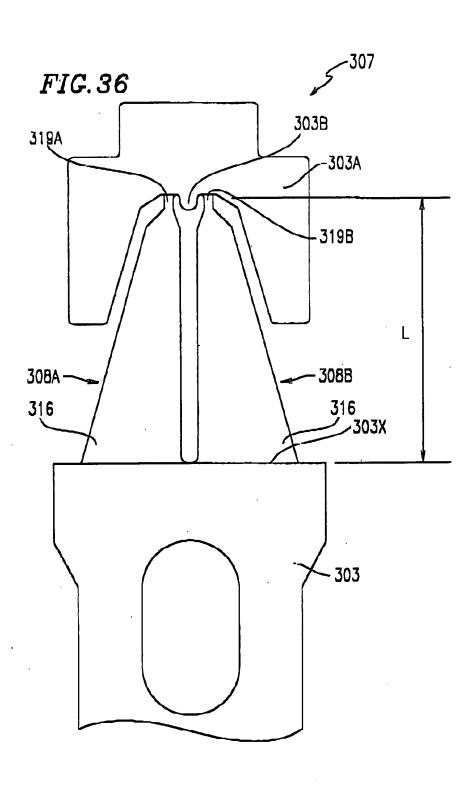




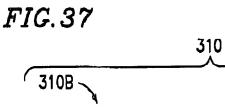


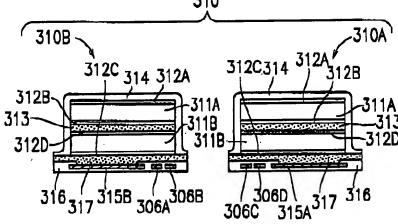


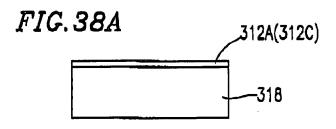
X2-X2 Cross section

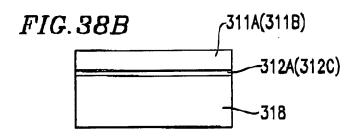


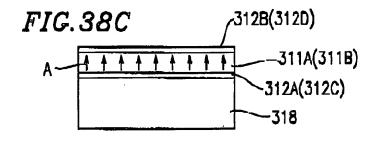
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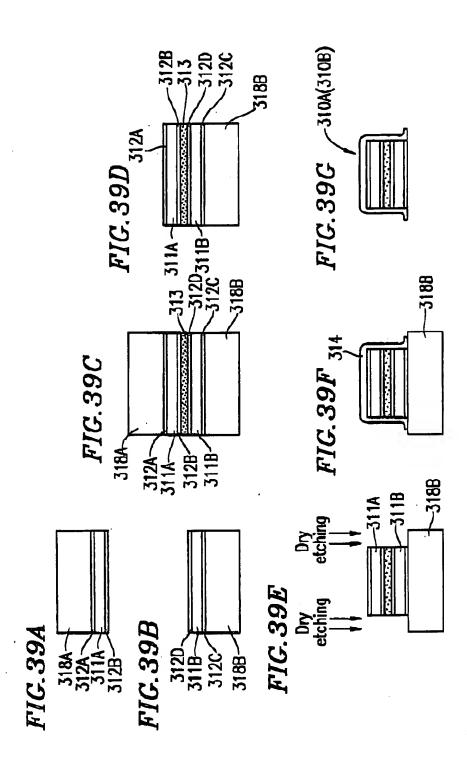












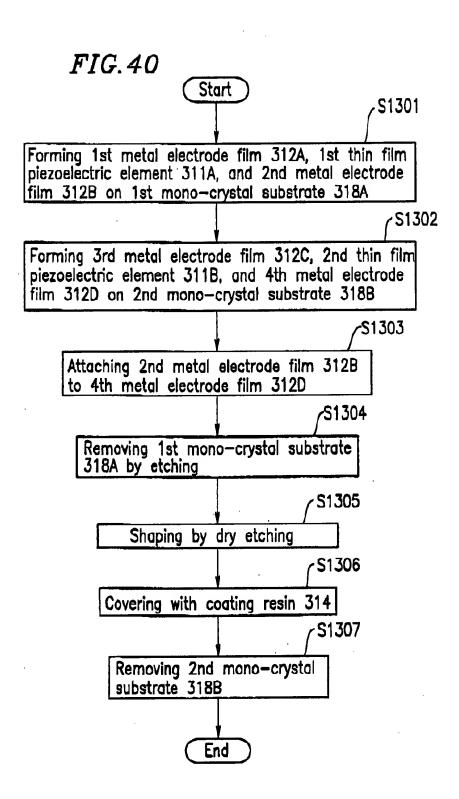
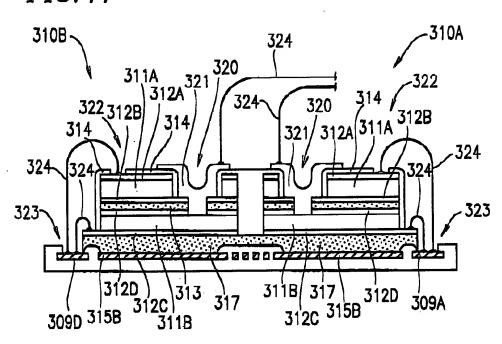


FIG.41



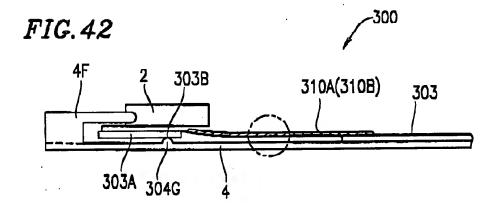


FIG. 43A

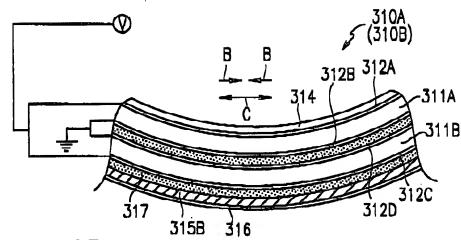


FIG. 43B

Voltage applied to thin film piezoelectric terminal 309A

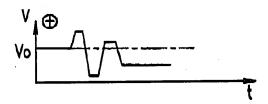
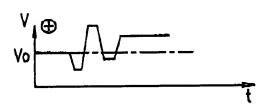
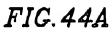


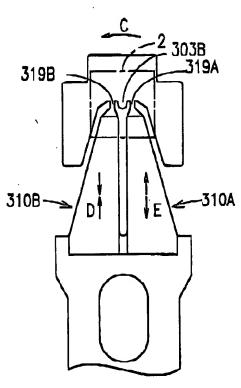
FIG. 43C

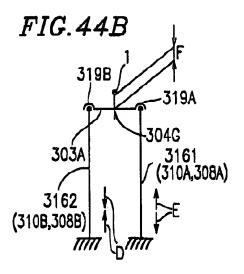
Voltage applied to thin film piezoelectric terminal 309D



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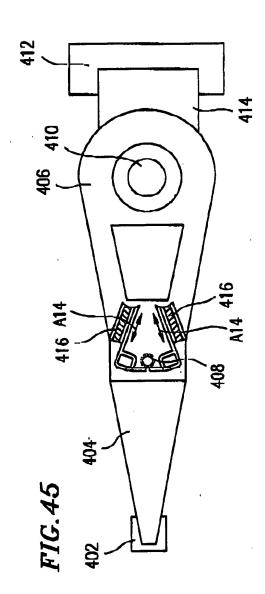




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